



FORM HDP-1449 (Based on Form PTO-1449)

PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE CITATION
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Sheet 1 of 3

ATTORNEY DOCKET No.	SERIAL No.
9319A-000762	10/824,335
APPLICANT	
Osamu SHINKAWA	
FILING DATE	GROUP
April 14, 2004	2853-2861

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Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
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Examiner: /Huan Tran/

Date Considered: 07/10/2007

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Sheet 2 of 3

ATTORNEY DOCKET NO.

9319A-000762

SERIAL NO.

10/824,335

APPLICANT

Osamu SHINKAWA

FILING DATE

April 14, 2004

GROUP

2853 2861

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1.	/HT/	Patent abstracts of Japan regarding Publication No. 08-309963 published 11/26/1996.
2.	/HT/	Communication from China Patent Office regarding counterpart application.

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